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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Inventor: Kenneth C. Johnson

Application No.: 10/611,298

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For: REDUCED MULTICUBIC DATABASE
INTERPOLATION METHOD FOR
OPTICAL MEASUREMENT OF
DIFFRACTIVE MICROSTRUCTURES

Confirmation No.: 5587

Group Art Unit: 2877

Examiner: Unknown

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CERTIFICATE OF MAILING

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